L	Hits	Search Text	DB	Time stamp
Number				
1	73963	(metal film) adj substrate	USPAT;	2002/03/06
Ì			US-PGPUB;	16:21
			EPO; JPO;	
			DERWENT	
7	1476	(metal film) adj substrate and	USPAT;	2002/03/06
		205/\$.ccls.	US-PGPUB;	16:22
			EPO; JPO;	i
			DERWENT	
13	459	(metal film) adj substrate and	USPAT;	2002/03/06
		205/\$.ccls. and 204/\$.ccls.	US-PGPUB;	16:23
		2007 4 1 0 0 1 20 1 7 4 1 0 0 1 2 1	EPO; JPO;	
			DERWENT	
19	38	(metal film) adj substrate and	USPAT;	2002/03/06
19]	205/\$.ccls. and 204/\$.ccls. and holder	US-PGPUB;	16:24
		203/7.ccis. and 204/7.ccis. and norder	EPO; JPO;	10.21
			DERWENT	
25	2	/motal film) add substrate and	USPAT;	2002/03/06
25	2	(metal film) adj substrate and		
]		205/96.ccls. and 204/\$.ccls. and holder	US-PGPUB;	16:24
			EPO; JPO;	
	1		DERWENT	